



IFW

In re the Application of: **HAEMATSU, Hitoshi**

Group Art Unit: **2822**

Serial No.: **10/659,337**

Examiner: **Pamela E. PERKINS**

Filed: **September 11, 2003**

P.T.O. Confirmation No.: **7094**

For: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 17, 2005

Sir:

In response to the Office Action dated **March 23, 2005**, please amend the above-identified application as follows: